

Attorney Docket: 30205/37916

Inventors: Kim et al.

Title: "Chemical Mechanical Polishing Slurry and Process for Ruthenium Films"

Sheet 1 of 3

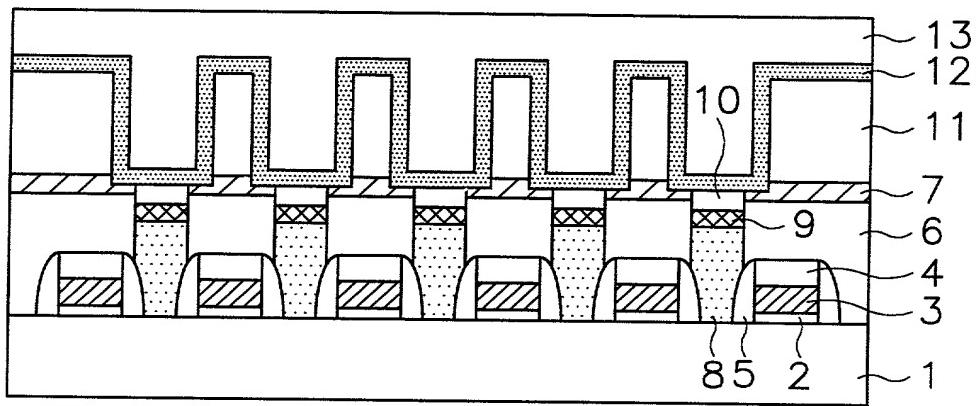


Fig.1

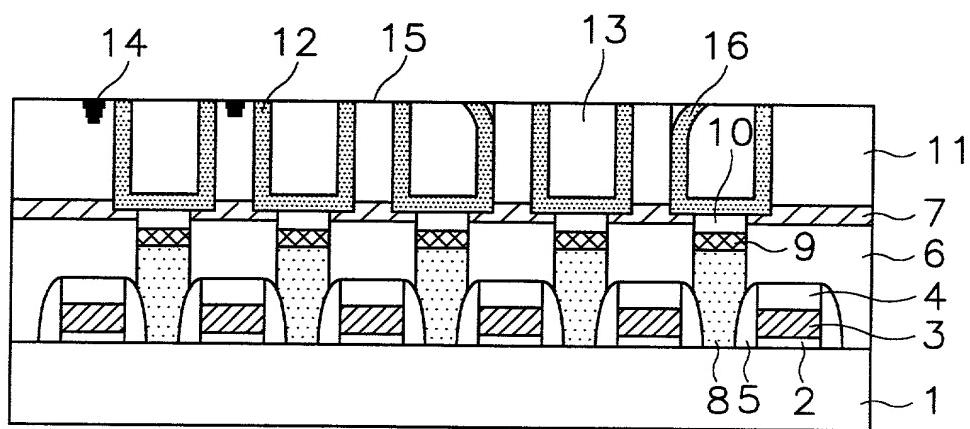


Fig.2

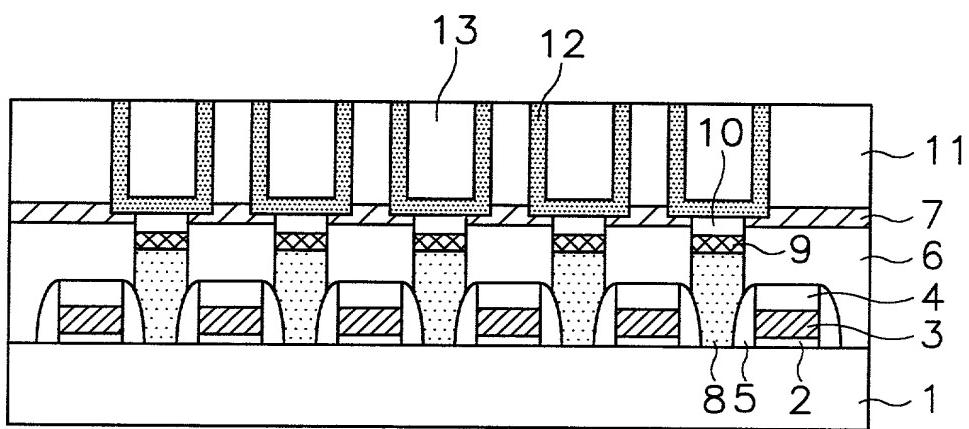


Fig.3